

Electronic Acknowledgement Receipt

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Application Number:	10601475
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Title of Invention:	Semiconductor wafers having asymmetric edge profiles that facilitate high yield processing by inhibiting particulate contamination
First Named Inventor:	Gi-Jung Kim
Customer Number:	20792
Filer:	Grant J. Scott/Candi Riggs
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Supplemental Response or Supplemental Amendment	Resp_to_NonResponsive_A.mdd.pdf	33152	no	1

Warnings:	
Information:	
Total Files Size (in bytes):	33152
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National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.	